

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/566,116	Confirmation No. 3700
Applicant	:	Akihisa Inoue et al.	
371 Filed	:	January 24, 2006	
Art Unit	:	1734	
Examiner	:	Weiping Zhu	
Customer No.	:	00270	
Title	:	SPUTTERING TARGET AND METHOD FOR PRODUCTION THEREOF	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response submitted in reply to a non-final Office Action dated January 20, 2011. A Petition for a One Month Extension of Time to extend the deadline for response from April 20, 2011 to May 20, 2010 is filed herewith.

Remarks/Arguments begin on page 2 of this paper.